



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hideomi Suzawa et al. Art Unit: 2812

Serial No.: 09/852,672 Examiner: Alexander G. Ghyka

Filed: May 11, 2001 Confirmation No.: 5083

Title : SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

SECOND REQUEST FOR INITIALED PTO FORM 1449

Further to a request filed November 5, 2004 and upon reviewing the file, applicants note that they have not yet received an initialed copy of the enclosed PTO Forms 1449 that accompanied the information disclosure statements filed June 12, 2002 and September 24, 2004.

On the PTO Form 1449 filed with the information disclosure statement dated June 12, 2002, please note that Desig. IDs AL through AN were initialed on another PTO Form 1449 filed with the <u>supplemental</u> information disclosure statement dated July 11, 2002. Therefore, the Examiner only needs to initial Desig. ID AA on the PTO Form 1449 filed with the information disclosure statement dated June 12, 2002.

Applicants' records show that these information disclosure statements complied with 37 CFR 1.97. Thus, it is respectfully requested that the Examiner initial and return these forms as soon as possible. Since applicants are paying the issue fee concurrently with this request, the Examiner's prompt attention to this matter would be appreciated.

Respectfully submitted,

Date: December 30, 2004

John F. Hayden

Reg. No. 37,640

Compatitute Form PTO-1449

U.S. Department of Commerce Patent and Trademark Office Attorney's Docket No. 12732-038001

Application No. 09/852,672

by Applicant
(Use several sheets if necessary)

Applicant Hideomi Suzawa et al.

Filing Date
May 11, 2001

Group Art Unit 2812

37 CFR \$1.98(b

TRACE			U.S. Pate	ent Documents			
Examiner Initial	Desig.	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
Hillai	AA	6,596,571	07/22/2003	ARAO et al.			06/05/2001
	AB	6,773,996	08/10/2004	SUZAWA et al.			05/10/2001
	AC	2001/0035526	11/01/2001	YAMAZAKI et al.			04/24/2001
	AD	2002/0110941	08/15/2002	YAMAZAKI et al.			01/26/2001
	AE	2002/0113552	08/22/2002	JUESTEL et al.			12/06/2001
	AF						
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	Foreign	Patent Doc	uments or Pu	blished Foreign	Patent A	Application	IS	
			Publication	Country or	Class	Subclass	Translation	
Examiner Initial	Desig. ID	Document Number	Date	Patent Office			Yes	No
	AL							
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	AN							
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	Other Do	cuments (include Author, Title, Date, and Place of Publication)
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next communication to applicant.